PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
United Epitaxy Company, Ltd.	03/03/2006

RECEIVING PARTY DATA

Name:	Epistar Corporation	
Street Address:	5 Li-Hsin 5th Rd., Science-Based Industrial Park	
City:	Hsinchu	
State/Country:	TAIWAN	
Postal Code:	300	

PROPERTY NUMBERS Total: 1

Property Type	Number
Patent Number:	6277665

CORRESPONDENCE DATA

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NAME OF SUBMITTER: Cynthia L. Pillote

Total Attachments: 1

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PATENT

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Snell & Wilmer L.L.P.

ASSIGNMENT

UTILITY PATENT

WHEREAS, the undersigned United Epitaxy Company, Ltd. ("ASSIGNOR"), a corporation having its principal place of business at 9F, No. 10, Li-Hsin Rd., Science-Based Industrial Park, Hsinchu, Taiwan, R.O.C., is owner by assignment from the original inventors of the invention entitled FABRICATION PROCESS OF SEMICONDUCTOR LIGHT-EMITTING DEVICE WITH ENHANCED EXTERNAL QUANTUM EFFICIENCY, for which Letters Patent of the United States has been granted by the U.S. Patent and Trademark Office on August 21, 2001, as Patent No. 6,277,665;

AND WHEREAS, Epistar Corporation (hereinafter "ASSIGNEE"), a corporation having its principal place of business at 5 Li-Hsin 5th Rd., Science-Based Industrial Park. Hsinchu, Taiwan, 300, R.O.C., is desirous of acquiring an interest therein;

NOW, THEREFORE, for good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, ASSIGNOR by these presents does sell, assign and transfer unto ASSIGNEE, its successors, assigns and legal representatives, the Assignor's full and exclusive right to the invention as described in the aforesaid patent, in the United States and all foreign countries, together with the right of priority under the International Convention for the Protection of Industrial Property, Inter-American Convention Relating to Patents, Designs and Industrial Models, and any other international agreements to which the United States adheres, and hereby authorizes and requests the Commissioner of Patents to issue a Certificate of Correction to said Letters Patent to ASSIGNEE, for the sole use and benefit of ASSIGNEE, its successors, assigns and legal representatives,

AND HEREBY AGREES to transfer a like interest upon request of ASSIGNEE, its successors, assigns and legal representatives, and without further remuneration, in and to any improvements and applications for patents based thereon, growing out of or relating to the invention; and to provide all reasonable assistance and execute any papers deemed essential by ASSIGNEE, its successors, assigns and legal representatives, to ASSIGNEE's full protection and title in and to the invention hereby transferred,

AGREEING, FURTHERMORE, upon request of ASSIGNEE, and without further remuneration, to execute any and all papers desired by ASSIGNEE for the filing and granting of foreign applications and the perfecting of title thereto in ASSIGNEE.

EXECUTED as of the date(s) written below by ASSIGNOR and ASSIGNEE;

ASSIGNOR:		ASSIGNEE:	
UNIT	ED EPITAXY COMPANY, LTD.	<u>EPIST</u>	TAR CORPORATION
Ву	(signature)	Ву	(signature)
	Tzer-Perng Chen (typed or printed name)		Biing-Jye Lee (typed or printed name)
	C.T.O. (typed or printed title)		President (typed or printed title)
Date:	Mar 3. 2006	Date:	Feb 27, 2006

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PATENT TOTAL P.02
REEL: 017353 FRAME: 0021